

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of:) Confirmation No. 2927
Osamu Nakamura)
Application No. 10/807,472) Examiner: Rakesh Kumar Dhingra
Filed: March 24, 2004) Group Art Unit: 1763
For: PLASMA TREATMENT APPARATUS)
) Date: August 24, 2006

AMENDMENT AFTER FINAL REJECTION

MAIL STOP AF
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

In response to the Office Action mailed April 24, 2006, please amend the above-captioned application as follows:

LIE:-

Please DO-NOT

enter

Rakesh
8/29/06